

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date March 19, 2003

In re the Application of

Akira SATO

Application No.: 09/424,500

Filed: February 22, 2000

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE



Group Art Unit: 2825

Examiner: G. Lee

Docket No.: 104788

2825
RECEIVED
MAR 24 2003
TC 2800 MAIL ROOM
201-1
#223
7/26/03

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired February 19, 2003, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 140352 in the amount of \$110.00 in payment for:

X Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
_____ Extension fee for response within second month pursuant to §1.136(a) (\$410.00)
_____ Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Benjamin M. Halpern
Registration No. 46,494

03/21/2003 AWONDAF1 00000143 09424500

01 FC:1251

110.00 OP

JAO:BMH/vgp

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461